10/043,561

UNITED STATES PATENT AND TRADEMARK OFFICE **CERTIFICATE OF CORRECTION**

PATENT NO.

: 6,770,565 B2

DATED

: August 3, 2004

INVENTOR(S) : Olgado et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 5,

Line 58, change "wafers" to -- wafer, --

Column 13,

Line 15, delete "field thickness".

Line 33, change "move slowly then" to -- more slowly than --.

Column 14,

Line 8, insert a comma after the first occurrence of "containing materials".

Signed and Sealed this

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Twenty-first Day of December, 2004

JON W. DUDAS

Director of the United States Patent and Trademark Office